Role of Ag addition in the structural transition of GeSbTe thin films <u>Palwinder Singh</u> (Advanced Materials Research Lab, Department of Basic and Applied Sciences, Punjabi University, Patiala-147 002, Punjab, India) Anup Thakur (Advanced Materials Research Lab, Department of Basic and Applied Sciences, Punjabi University, Patiala-147 002, Punjab, India) <u>palwinder1263@gmail.com</u>

Abstract:

Amorphous to polycrystalline phase transition, accompanied by a drastic change in optical and electrical properties, on the nanosecond timescale, makes $Ge_2Sb_2Te_5$ (GST) a central candidate for various technological applications. Phase transition in GST can be achieved by applying a variety of ways, such as laser pulses, voltage pulses, local heating, and pressure. Presently, GST is a potential candidate for resistive switching, phase change random access memory (PCRAM), optical data storage, active lattice tuning photonic components, and IR-reversible window.

 $(Ge_2Sb_2Te_5)_{100-x}Ag_x$ (x = 0, 1, 3, 5 and 10) bulk alloys were prepared from highly pure (99.999%) Ge, Sb, Te and Ag elements using melt quenching technique. Thin films of prepared alloys were deposited on glass substrate using thermal evaporation technique under high vacuum ~5×10⁻⁶ mbar. Thickness of thin films was measured *in-situ* using digital thickness monitor (DTM-101). Deposited thin films were annealed at different temperature in vacuum. Structural properties of as-deposited and annealed thin films were determined from X-ray diffraction (XRD) patterns. Optical properties were studied from transmission spectra taken in the wavelength range of 800-3300 nm using UV-Vis-NIR spectrophotometer. Survey and core level spectra (Ge 3d, Te 3d, Sb 3d and Ag 3d) of thin films were taken using lab source X-ray photoelectron spectroscopy setup. Ge *K*-edge of all thin films was measured to study the local arrangement around Ge element.

Composition of prepared bulk samples and thin films was verified using energy dispersive X-ray spectroscopy and found to be comparable with starting stoichiometry. XRD patterns of as-deposited thin films did not contain any sharp peak and revealed the amorphous nature. Phase transition was observed with annealing. Optical band gap increases with Ag addition upto 3% and then starts decreasing at higher Ag content. Atomic arrangement was investigated from X-ray absorption spectroscopy. Effect of Ag on electronic structure of GST thin film was studied from X-ray photoelectron spectroscopy.

In the present study, role of Ag addition on optical, structural, atomic and electronic properties is investigated.

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